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Influence of Containment on the Growth of Silicon-Germanium: A Materials Science Flight Project

M. P. Volz¹, K. Mazuruk², A. Cröll³

¹NASA, Marshall Space Flight Center, EM31, Huntsville, Alabama, USA ²University of Alabama in Huntsville, Huntsville, Alabama, USA ³University of Freiburg, Freiburg, Germany





- "Influence of Containment on the Growth of Silicon-Germanium" (ICESAGE) is a NASA Materials Science Flight Investigation
- ICESAGE is a collaborative investigation between NASA and the European Space Agency (ESA)
- The ICESAGE experiments will be conducted in the Low Gradient Furnace (LGF) in the Materials Science Laboratory on the International Space Station (ISS)



Materials Science Laboratory

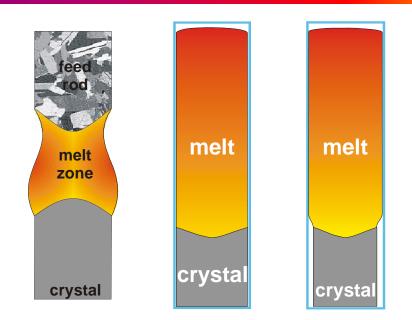


Overview of the Investigation



This investigation involves the comparison of results achieved from three types of crystal growth of germanium and germanium-silicon alloys:

- •Float zone growth
- •Bridgman growth
- •Detached Bridgman growth



The fundamental goal of the proposed research is to determine the influence of containment on the processing-induced defects and impurity incorporation in germanium-silicon (GeSi) crystals (silicon concentration in the solid up to 5 at%) for three different growth configurations in order to quantitatively assess the improvements of crystal quality possible by detached growth.



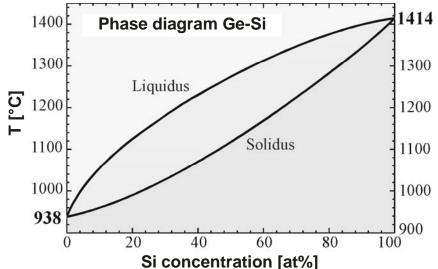


- Technological applications
 - X-ray and neutron optics (gradient crystals)
 - High-efficiency solar cell material
 - Thermoelectric converters
 - Increased carrier mobility compared to silicon, but can still be integrated into Si technology
- Characterization methods for silicon and germanium are well-established and are applicable to the alloy crystals.
- Relatively well known material properties and material parameters
- The vapor pressure of silicon and germanium melts can be neglected; they are non-toxic materials.



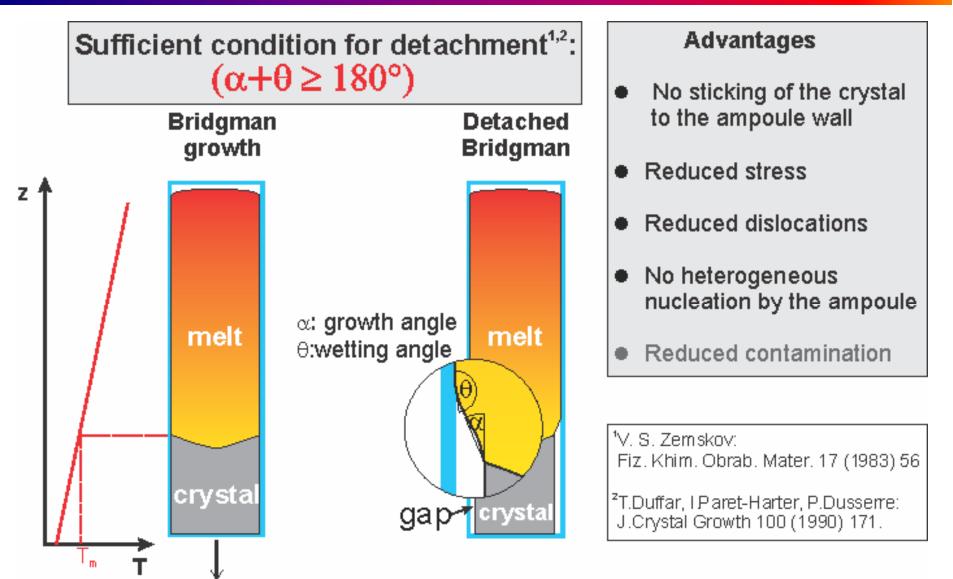


- Large separation of solidus and liquidus curves leads to strong segregation
- Lattice mismatch (4%) leads to increased stress, cracks, high dislocation densities, polycrystalline growth
- The reactivity of liquid silicon leads to a reaction with crucible materials (sticking) as well as contamination of the melt and the crystals





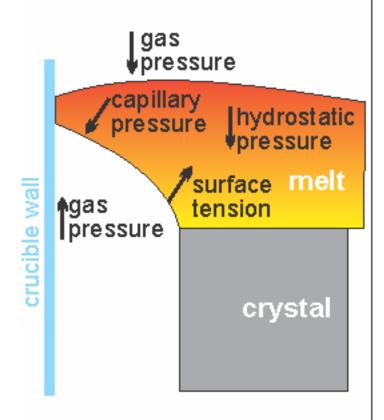








Active Forces (schematic)



$$\gamma\left(\frac{1}{R_1} + \frac{1}{R_2}\right) = \Delta P$$
 Young-Laplace Equation

where

 γ : surface tension

 R_1, R_2 : radii of curvature of the meniscus

 ΔP : pressure differential across the meniscus

$$\Delta P = \Delta P_{external} + \rho g h + 2 \frac{\gamma}{r_{tm}}$$

where

 $\Delta P_{external}$: external gas pressure differential ρgh : weight of melt (pressure head)

 $2\frac{\gamma}{r_{tm}}$: capillary pressure from top meniscus



Calculation of Meniscus Shapes



$$\frac{\frac{d^2 z}{dr^2}}{\left(1 + \left(\frac{dz}{dr}\right)^2\right)^{3/2}} + \frac{\frac{dz}{dr}}{r\left(1 + \left(\frac{dz}{dr}\right)^2\right)^{1/2}} = \Delta P - Bz(r)$$

$$\Delta P = \frac{\Delta P_m r_0}{\sigma}, \quad \Delta P_m = P_H - P_C + \rho gh + 2\frac{\sigma}{r_H}$$

$$B = \frac{\rho g_0 r_0^2}{\sigma} \qquad B = 3.248; \text{ Ge, } r_0 = 6 \text{ mm}$$

$$B = 4.651; \text{ lnSb, } r_0 = 5.5 \text{ mm}$$

Young-Laplace Equation

 ΔP : Dimensionless pressure differential across the meniscus

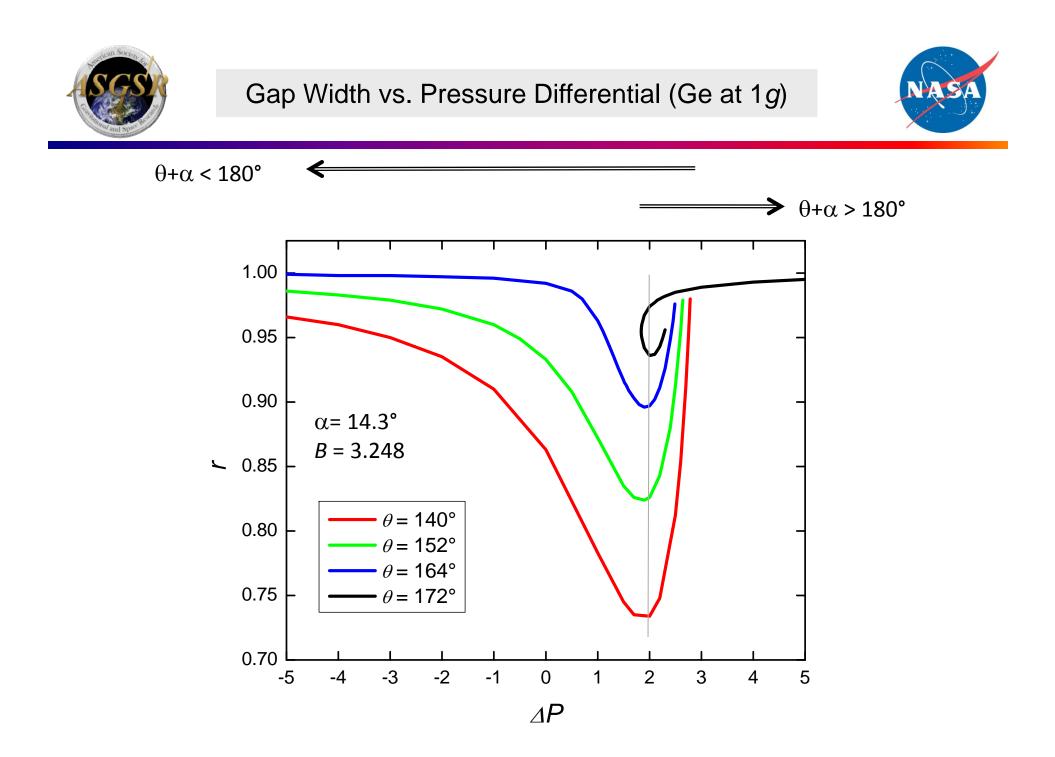
B : Bond number; ratio of gravity force to surface tension force

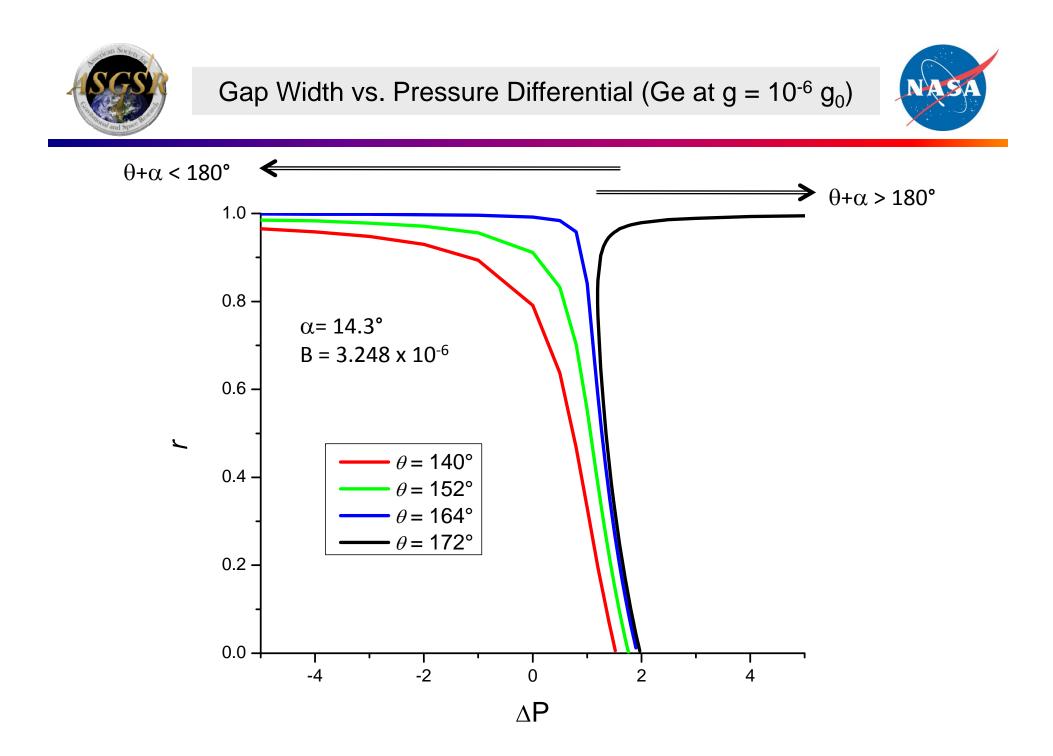
$$\frac{\partial r}{\partial s} = \cos \beta, \quad \frac{\partial z}{\partial s} = \sin \beta, \quad \frac{\partial \beta}{\partial s} = -\frac{\sin \beta}{r} + \Delta P - Bz$$

Set of 3 coupled differential equations

Boundary Conditions $z(0) = 0; \ \beta(0) = 90^{\circ} - \alpha;$ $\beta(1) = \theta - 90^{\circ}; \ r(1) = 1$

 α : growth angle θ : contact or wetting angle

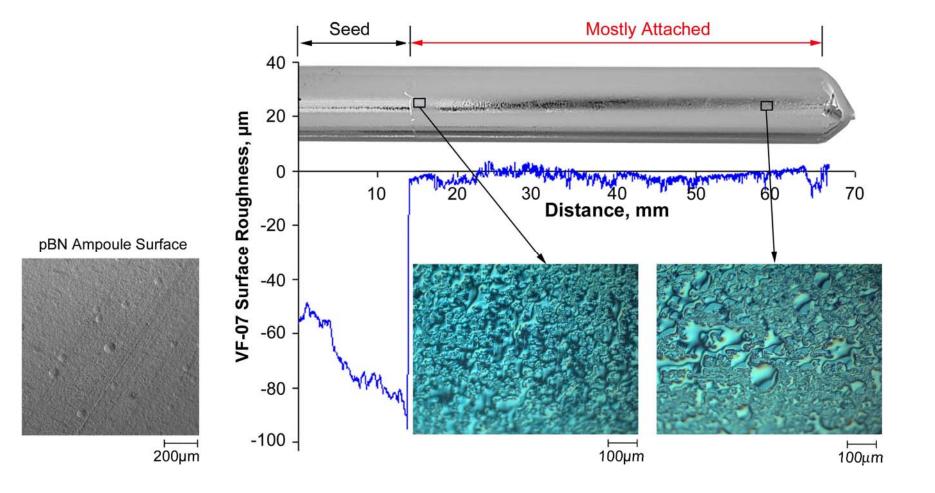






"Attached" Germanium

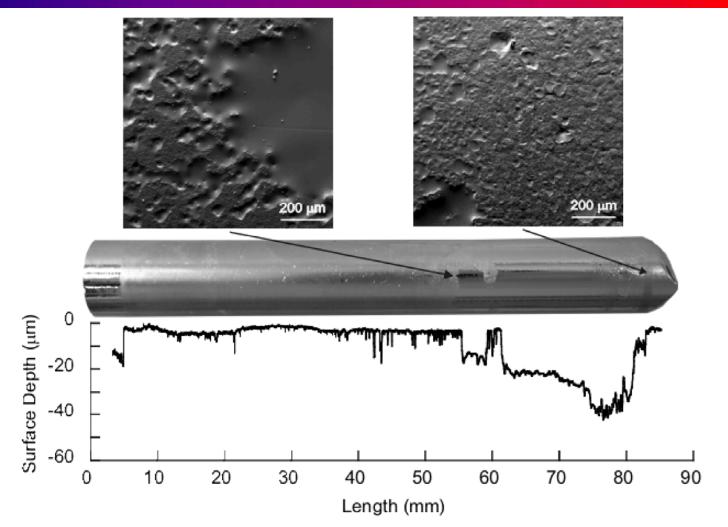






Partially Attached GeSi



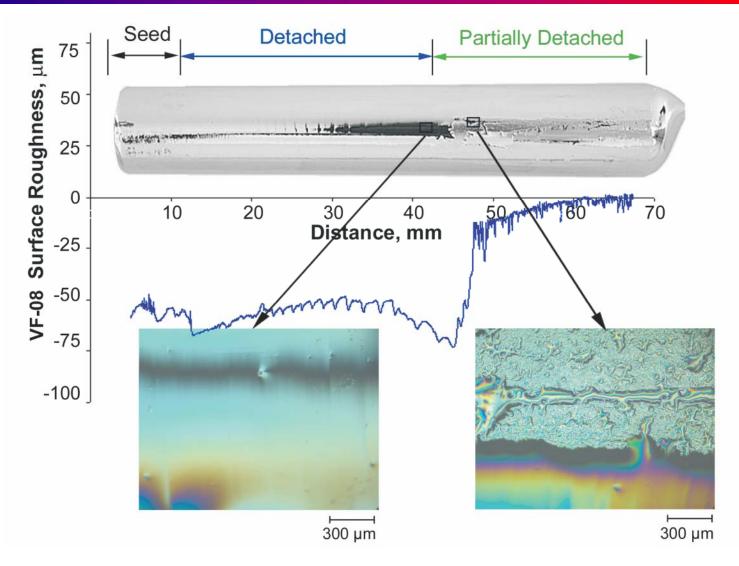


M. P. Volz, M. Schweizer, N. Kaiser, S. D. Cobb, L. Vujisic, S. Motakef, F. R. Szofran, *JCG* 237-239 (2002) 1844-1848



Detached Ge in pBN Ampoule









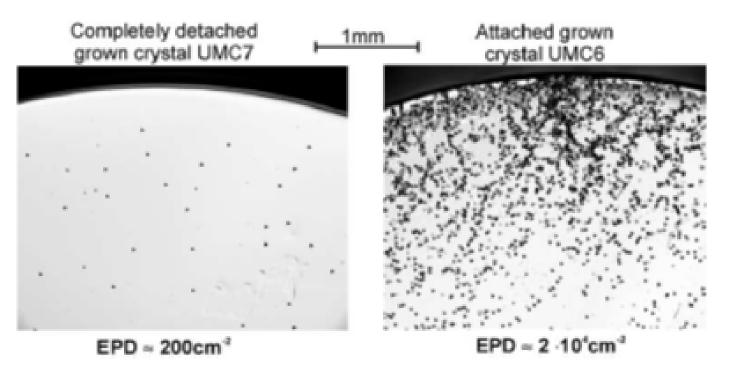


Fig. 5. Micrograph from the detached-grown sample UMC7 and from the attached-grown sample UMC6.

M. Schweizer, S. D. Cobb, M. P. Volz, J. Szoke, F. R. Szofran, JCG 235 (2002) 161-166





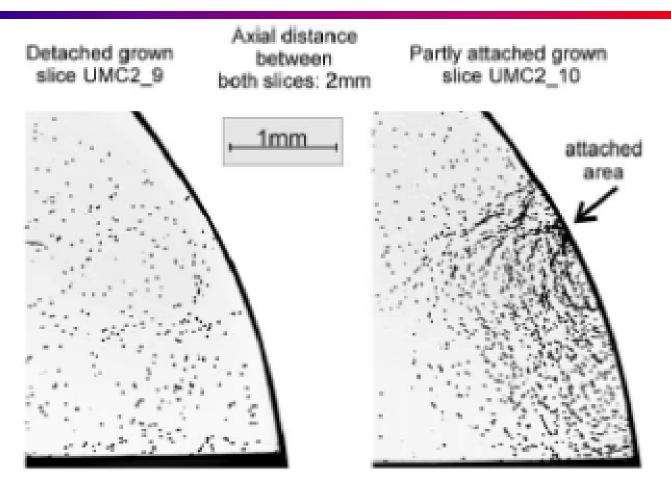


Fig. 6. Localized increased EPD after the crystal attaches partially to the wall.

M. Schweizer, S. D. Cobb, M. P. Volz, J. Szoke, F. R. Szofran, JCG 235 (2002) 161-166





- Microgravity reduces the pressure head (pgh) resulting from the weight of the melt.
 - Detached growth requires that capillary forces dominate over gravitational forces.
 - On Earth, gravity complicates a comparison of detached growth theory and experiment: the pressure head continuously decreases as the melt solidifies and the pressure varies along the height of the meniscus.
- Microgravity allows a larger value of the gap width.
 - On Earth, when the gap width becomes too large, gravity overcomes surface tension, a stable meniscus cannot be maintained, and the melt will flow down between the crystal and ampoule wall.
 - A large initial gap width will allow measurement of anisotropy in the growth angle.
- Microgravity enables a study of the dynamic stability of crystallization independent of thermal effects.





Ten flight experiments have been selected to address the flight objectives of the Bridgman component of the ICESAGE investigation.

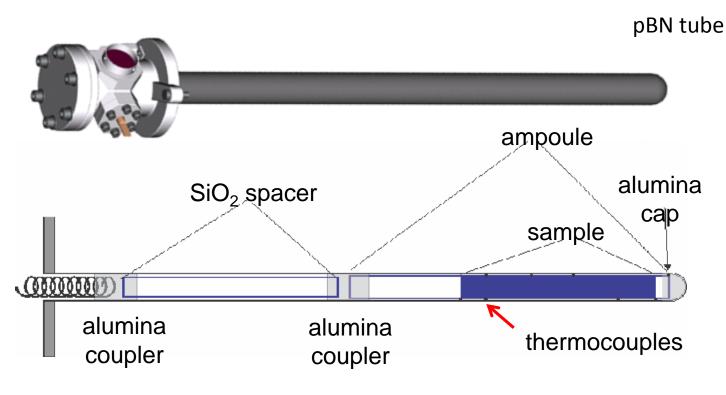
- 1) Test the following detached growth hypotheses:
 - a. For a given set of growth and contact angles, there exists a range of pressure differential between the upper surface of the melt and the meniscus at the detachment gap such that detachment occurs.
 - b. Larger gap widths are possible in microgravity than in unit gravity.
 - c. Dynamic stability of detached growth in microgravity does not depend on thermal effects.
 - d. Measurement of the growth angle anisotropy can be made in detached growth in microgravity.
- 2) Quantitatively compare the defect structure and impurity levels of microgravity-grown normal and detached Bridgman and float-zone crystals to determine the optimum growth process.







- A Ge_{1-x}Si_x ingot is placed inside a pyrolitic boron nitride (pBN) tube and sealed in a SiO₂ ampoule.
- The ampoule is placed inside a cartridge which is inserted into the furnace.
- Thermocouples in the cartridge provide for real-time monitoring of the thermal profile







Dr. Frank R. Szofran (original U.S. PI), NASA MSFC, Huntsville, ALUSA

- **Dr. Peter Dold** (original German PI), Kristallographisches Institut, Freiburg, Germany
- Prof. Dr. Klaus Werner Benz, Kristallographisches Institut, Freiburg, Germany
- Dr. Sharon D. Cobb, MSFC, Huntsville, ALUSA
- Dr. Natalie Kaiser, Kristallographisches Institut, Freiburg, Germany
- Mr. Uwe Kerat, Kristallographisches Institut, Freiburg, Germany
- Ms. Alina Mitric, Kristallographisches Institut, Freiburg, Germany
- Dr. Shariar Motakef, CAPE Simulations, Inc., Newton, MAUSA
- Dr. Witold Palosz, USRA/MSFC, Huntsville, ALUSA
- Ms. Penny Pettigrew, Morgan Research/MSFC
- Dr. Markus Schweizer, USRA/MSFC, Huntsville, ALUSA
- Dr. Ljubomir Vujisic, Cape Simulations, Inc., Newton, MAUSA
- Prof. John S. Walker, University of Illinois at Urbana-Champaign, Urbana, IL USA
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